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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Shrinivasan et al.

Attorney Docket No.: NOVLP029/NVLS-000495

Application No.: 10/067,520

Examiner: Not yet assigned

Filed: February 5, 2002

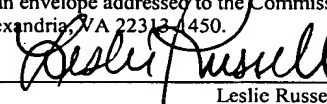
Group: 2811

Title: APPARATUS AND METHODS FOR
PROCESSING SEMICONDUCTOR
SUBSTRATES USING
SUPERCRITICAL FLUIDS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on December 24, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:


Leslie Russell

AMENDMENT TRANSMITTAL

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

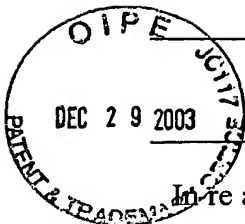
	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	59	MINUS	111	0	x 9 =	x 18 = 0.00
Independent Claims	0	MINUS	5	0	x 43 =	x 86 = 0.00
Multiple Dependent Claim Present and Fee Not Previously Paid					\$145.00	\$290.00
Total					\$	\$0.00

- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. NOVLP029).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP


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Berkeley, CA 94704-0778



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PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Before examination on its merits, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which being on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.